

Silicon Tetrafluoride, a New Fluorinating Agent

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Silicon tetrafluoride is a new, low cost fluorinating agent for organic chlorine compounds. The application of the reaction is limited by the thermal stability of the chlorinated starting materials. The new method is especially useful for the preparation of fluorochloromethanes and carbonyl fluorochloride.

Many attempts have been made in the past to utilize the fluorine values of silicon tetrafluoride, a waste product of fertilizer manufacture, for fluorination reactions. Processes are known in which the silicon tetrafluoride is converted into hexafluorosilicates and used in this form as fluorinating agents.¹⁻³ These processes, however, involve troublesome operations (corrosion and filtration problems), which prevent their industrial application. Recently the formation of ethyl fluoride from ethyl orthoformate and silicon tetrafluoride was reported,⁴ but this reaction is run in the liquid phase with catalysts and does not seem to be generally applicable. Apparently it is limited to highly reactive compounds such as ortho esters.

The use of silicon tetrafluoride as fluorinating agent in the vapor phase at elevated temperatures was investigated for both inorganic⁵ and organic compounds. The reactions of the following organic compounds with silicon tetrafluoride were studied: carbon tetrachloride, chloroform, phosgene, carbon dioxide, perchloroethylene, pentachloroethane, hexachloropropylene, chlorobenzene, and hexachlorobenzene. The silicon tetrafluoride is hereby converted to fluorochlorosilanes.

All reactions were carried out by passing the vapors of the chlorine compound together with an excess of silicon tetrafluoride through an electrically heated quartz tube. In most reactions the quartz tube was filled with Hengar quartz granules, in order to achieve a better heat transfer. In a few cases the use of catalysts was investigated, but no catalytic effects were observed. The reaction products were condensed in cold traps and analyzed by gas chromatography and infrared spectroscopy.

Table I gives a summary of the results obtained. It shows that SiF₄ is able to replace chlorine by fluorine in -CCl₃ groups of high enough thermal stability. In the case of carbon tetrachloride as starting material a mixture of the different fluorochloromethanes is obtained in good yields. At lower temperatures the formation of CFCl₃ is favored; at higher temperatures that of CF₂Cl₂. Therefore it is possible to use this process for the production of either fluorochloromethane by selecting the most suitable temperature range for each fluorocarbon.

Hexachloropropylene can be fluorinated under much milder conditions, due to the activation of the allylic chlorine atoms. The fluorination occurs exclusively in the -CCl₃ group.

In the case of chloroform there are two competitive reactions: the fluorination and the thermal decomposition of CHCl₃. At lower temperatures the yield of

CHFCl₂ is higher, but the conversion of the starting material is low. At higher temperatures the conversion of the starting material increases, but at the same time thermal decomposition starts. Among other products carbon tetrachloride was formed and, therefore, the occurrence of CFCl₃ and CF₂Cl₂ in the reaction mixture can be explained.

Phosgene gives fluorochlorophosgene in 100% yield and conversions higher than 40% per pass. No difluorophosgene is formed under these conditions. This reaction proceeds at temperatures as low as 400°. At higher temperatures the yield of COFCl stays at 100%, but the conversion of the starting material drops. This can be explained by the shifting of the equilibrium between CO + Cl₂ ⇌ COCl₂ above 500° toward the left side. This fact apparently influences the fluorination reaction. A carbonyl group cannot be fluorinated, as can be shown by the reaction of COCl₂ and CO₂ with SiF₄.

Perchloroethylene gives high yields of CFCl=CCl₂, but the conversion of the starting material remains low, due to the relatively unreactive chlorine atoms in this compound. Attempts to achieve higher conversions by the use of different catalysts, such as HCl, BF₃, and AlF₃, were not successful. Pentachloroethane does not possess a high enough thermal stability, since it is dehydrohalogenated at relatively low temperature to perchloroethylene.

The fluorination of aromatic compounds such as monochlorobenzene and hexachlorobenzene was attempted, but no fluorine-containing products could be obtained. Apparently the chlorine atom in these compounds is too unreactive.

Experimental

Materials.—Silicon tetrafluoride, phosgene, hydrogen chloride, boron trifluoride, and carbon dioxide were purchased from Matheson. The quartz granules, used as filling material of the reactor, were purchased from Hengar. The aluminum trifluoride catalyst on asbestos as a carrier was prepared in our laboratory. All the other chemicals were purchased from chemical supply houses.

Fluorination of CCl₄.—A stream of silicon tetrafluoride measured with a flowmeter was passed through a vessel containing CCl₄. The temperature of the CCl₄ container was kept with an oil bath at about 50° corresponding to a vapor pressure of CCl₄ of 300 mm. The SiF₄-CCl₄ mixture was subsequently passed through an electrically heated quartz tube, which was filled with Hengar quartz granules. The length of the heated zone was 33 cm. and the diameter of the tube was 2.5 cm. The reaction products were scrubbed with aqueous sodium hydroxide solution in order to eliminate all the silicon-containing compounds and analyzed by gas chromatography and infrared spectroscopy. The aqueous solution was checked for Cl⁻. Four qualitative reactions were run with a contact time of 10 sec. at different temperatures. The products showed the following composition: 500°, only starting materials; 600°, 20% CF₂Cl₂, 80% CFCl₃, and unreacted CCl₄; 700°, 25% CF₂Cl₂, 75% CFCl₃, and unreacted CCl₄; and

(1) J. Dahmlos, U. S. Patent 2,935,531 (1960).

(2) J. Dahmlos, U. S. Patent 3,113,157 (1963).

(3) Wasag-Chemie A. G. British Patent 909,078 (1962).

(4) K. G. Mason, J. A. Sperry, and E. S. Stern, *J. Chem. Soc.*, 2558 (1963).

(5) K. O. Christe and A. E. Pavlath, *ibid.*, in press.

TABLE I
VAPOR PHASE FLUORINATION OF ORGANIC COMPOUNDS WITH SILICON TETRAFLUORIDE^a

Starting material	Temp., °C.	Contact time, sec.	Vapor pressure of starting material, (mm. Hg)	Conversion of starting material, (%)	CF ₃ Cl	CF ₂ Cl	CFCl ₂	CFCl ₂ CCl=CCl ₂	CFCl ₂ CCl=CCl ₂	CFCl ₂	CFCl ₃	Yield, %
CCl ₄	600	10	300	57.8	...	18.9	CFCl ₃	81.1
	800	10	300	77.1	17.2	51.3	CFCl ₃	31.5
CCl ₃ CCl=CCl ₂	420	10	100	83	59.1	25.5
	520	7	100	87	56.8	31.0
CHCl ₃	450	10	100	3.2	47.0	CFCl ₃	...
	500	10	100	4.25	34.7	CFCl ₃	26.7
	550	10	100	7.1	31.1	CFCl ₃	24.0
	670	4	100	71.7	...	1.4	CFCl ₃	39.6
COCl ₂	360	15	380	3.66	COFCl ^b	Dec. of COCl ₂ → CO + Cl ₂
	420	15	380	42.4	100	0
CO ₂	500	6	200	0.3	100	0
	600	6	200	0.4	100	0
	800	6	200	2.9	82.9	13.8
	400-650	7-3	200	Only dehydrohalogenation, but no fluorination
CHCl ₂ CCl ₃	480-700	5	100	No reaction or decomposition
	500-800	10	200	No reaction or no fluorination
Chlorobenzene	500	6	200	0.3	CFCl=CCl ₂	CCl ₄
	600	6	200	0.4	100
Hexachlorobenzene	800	6	200	2.9	82.9	13.8
	400-650	7-3	200	Only dehydrohalogenation, but no fluorination
CO ₂	480-700	5	100	No reaction or decomposition
	500-800	10	200	No reaction or no fluorination

^a In all cases the quartz tube was filled with Hengar quartz granules in order to achieve a better heat exchange. All reactions were run at atmospheric pressure. ^b The amount of CO + Cl₂ formed was considered for the calculation of the yield as starting material and not as reaction product, since CO + Cl₂ can be easily recombined to phosgene.

800°, 17% CF₃Cl, 52% CF₂Cl₂, 31% CFCl₃, and unreacted CCl₄. The results of two quantitative runs at 600 and 800° are included in Table I.

Fluorination of CCl₃CCl=CCl₂.—The reactions were run in the same way as described above for the CCl₄. The CCl₃CCl=CCl₂-containing vessel was kept by an oil bath between 130 and 140° and the inlet to the reactor was heated by an infrared lamp in order to avoid condensation of the starting material. Two reactions were run at 420 and 520°. The conversions and yields are given in Table I.

Fluorination of CHCl₃.—The reactions were run in the same way as described above for the CCl₄. The CHCl₃ container was kept at room temperature. Table I shows the results of four reactions between 450 and 670°.

Fluorination of COCl₂.—A 1:1 mixture of COCl₂ and SiF₄ was passed through an electrically heated quartz tube, filled with Hengar quartz granules. The reactions were run at different temperatures and the reaction products were condensed in two cold traps at -78 and -196°. The condensed products were transferred to the vacuum line and analyzed by gas chromatography, fractionation, and infrared spectroscopy. Three qualitative reactions at 500, 650, and 850° and five quantitative reactions between 360 and 700° were run. The results of the quantitative reactions are given in Table I.

Fluorination of CO₂.—Two reactions between CO₂ and SiF₄ were run in the same way as described above for COCl₂. Infrared analysis and gas chromatographic investigation of the reaction products showed that no reaction had occurred between the starting materials.

Fluorination of CCl₂=CCl₂.—The reactions were run in the same way as described for CCl₄. The CCl₂=CCl₂ container was

kept at 80°. Four reactions were run with Hengar quartz granules as filling material. The results of these four reactions are given in Table I. In addition, three reactions between 500 and 800° were run using 15% of gaseous HCl as a catalyst. No improvement of the results could be obtained. In the same way, the addition of 10% BF₃ to the starting materials did not increase the amount of fluorinated products, as could be shown by three reactions between 500 and 800°. In another attempt the filling material of the reaction tube was replaced by an aluminum trifluoride catalyst on asbestos as carrier and three reactions were run between 550 and 850°, but also in this case no improvement of the results could be obtained.

Fluorination of CHCl₂CCl₃.—The reactions were run in the same way as described for CCl₄. The vapor pressure of CHCl₂CCl₃ was kept at 200 mm. Three reactions were carried out and showed the following results: at 400°, 7-sec. contact time—1.6% CHCl=CCl₂, 30.8% CCl₂=CCl₂, and 67.6% starting material; at 500°, 6-sec. contact time—3.6% CHCl=CCl₂, 91.2% CCl₂=CCl₂, 3.9% starting material, and 1.3% CCl₄; at 650°, 3-sec. contact time—0.3% CHCl=CCl₂, 84.7% CCl₂=CCl₂, 14.5% starting material, and 0.5% CCl₄. No fluorinated products were observed.

Fluorination of Aromatic Chlorine Compounds.—Three reactions between chlorobenzene and SiF₄ were run in the same way as described for CCl₄. At 480 and 600° no reaction occurred; at 700° the starting material started to decompose. Four reactions between hexachlorobenzene and SiF₄ were run. The hexachlorobenzene was placed in a quartz boat at the entrance of the tubular reactor and sublimed through the hot reaction tube. The reactions were run at 500, 650, 750, and 800°, but no fluorinated aromatic compounds could be obtained, as could be shown by n.m.r., infrared spectroscopy, and gas chromatography.

The Meerwein Arylation of Vinyl Sulfones¹

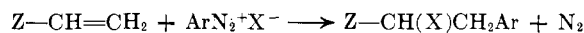
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Meerwein arylation of vinyl sulfones with aromatic diazonium salts was shown to yield α -halo- β -aryl sulfones. Despite low yields, the reaction provides a convenient route to these comparatively inaccessible compounds.

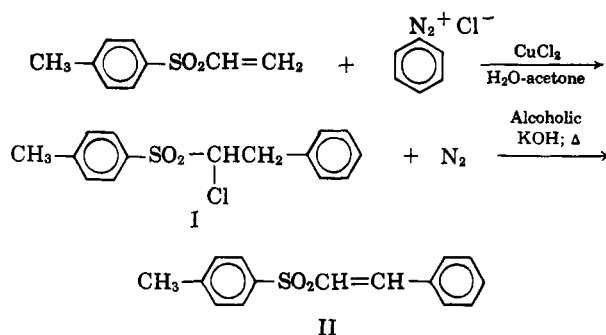
The Meerwein arylation of vinyl sulfones was investigated as a synthetic approach to α -chloro- β -aryl sulfones [RSO₂CH(Cl)CH₂Ar], since methods for preparing such compounds are limited. The Meerwein reaction² normally gives a product in which the incoming halo substituent occupies a position α , and the incoming aryl group occupies a position β , to the activating, electron-withdrawing substituent.



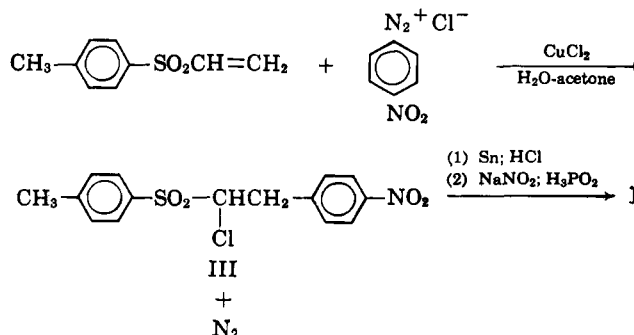
Although a wide variety of olefins has been subjected to the Meerwein reaction, at the beginning of our investigation there were no reports in the literature of Meerwein arylations of vinyl sulfones.

Arylation of *p*-tolyl vinyl sulfone with benzenediazonium chloride produced an adduct in 15–20% yield. The 1-chloro-2-phenylethyl *p*-tolyl sulfone structure (I) was assigned to this product on the basis of its dehydrohalogenation product, ω -styryl *p*-tolyl sulfone. This dehydrohalogenation was smoothly effected by refluxing I in alcoholic potassium hydroxide.

Arylation of *p*-tolyl vinyl sulfone with *p*-nitrobenzenediazonium chloride produced an adduct in 20–30% yield, which was assigned the 1-chloro-2-(*p*-nitro-



phenyl)ethyl *p*-tolyl sulfone structure (III). Compound III was converted into I by removal of the nitro group as indicated.



(1) Abstracted from the Ph. D. Thesis of J. E. Tracy Purdue University, 1965.

(2) C. S. Rondestvedt, Jr., *Org. Reactions*, **11**, 189 (1960).